



BOX AFTER FINAL
EXPEDITED PROCEDURE
GROUP ART UNIT: 2818
Docket No. 740819-408

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
In re PATENT application of:
Hiroaki NAKAOKA et al.
Application Serial No. 09/640,519
Filed: August 17, 2000
For: METHOD OF FABRICATING
SEMICONDUCTOR DEVICE
Examiner: D. Vu
Art Unit: 2818

REQUEST FOR RECONSIDERATION

BOX AF
Commissioner for Patents
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated **September 26, 2001**, the period for response having been extended one (2) months until **February 26, 2002**, the following remarks are respectfully submitted in connection with the above-identified application.

REMARKS

Applicant would like to thank the Examiner for the telephone conference February 1, 2002, in which the Examiner agreed to withdraw the finality of the Office Action as a result of a lack of full consideration being afforded to claim 1.

The Office Action of **September 26, 2001** has been received and its contents carefully noted. Applicant submits that this response is timely filed and fully responsive to the Office Action. Claims 1-10 are currently pending in the present application and are believed to be in condition for allowance at least for the reasons advanced hereinbelow.

The Office Action rejects claims 1, 3 and 5-9 under 35 U.S.C. §102(b) as